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CONFIRMATION NO. 7182

SERIAL NUMBER 10/20/2004 CLASS 438 GROUP ART UNIT 2822 ATTORNEY DOCKET NO. 0756-7251 APPLICANTS Shunpei Yamazaki, Setagaya, JAPAN; 0 . K CONTINUING DATA This application is a DIV of 10/124,344 04/18/2002 ABN which is a DIV of 09/337,333 08/21/1999 PAT 6,380,046 FOREIGN APPLICATIONS JAPAN 10-174482 06/22/1998 IF REQUIRED, FOREIGN FILING LICENSE GRANTED '' 04/21/2004 Foreign Priority claimed yes a senionalison with the control of the c											
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